<u>**AEMsApplications – Fluids</u></u></u>**

ROCHESTER INSTITUTE OF TEHNOLOGY MICROELECTRONIC ENGINEERING

Microelectromechanical Systems (MEMs) Applications – Fluids

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<u>**MEMsApplications**</u>-Fluids

INTRODUCTION

Micro Fluidics Conference

Drug Discovery: High-throughput profiling of screening results, liquid chromatography library screening, a case study of a big pharma discovery operation's use of microfluidic screening technology and the acceleration of ion channel lead discovery.

Clinical Diagnostics: Case studies on the use of BioMEMS technology in two high volume diagnostics laboratories. The miniaturization and acceleration of diagnostic devices.

Drug Delivery: An exciting new applications field – hear about next generation fluidic microsystems used for localized therapy, including implantable biocapsules, microneedles, and electrophoretic patches.

Proteomics: Receive brand new results on applications in small molecule validation, biomarker discovery, toxicological studies, and mass spectrometry.

Sample Preparation: New fraction collection systems, integration of sample prep steps using channel structures, novel sample partitioning technology and reconfigurable field transport geometries.

Device Engineering and Microfabrication: Fluid handling in an integrated device. The integration of individual analysis components. Case studies of microdevice manufacturing techniques – including the engineering stage, production equipment, and post-production processes.



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INTRODUCTION

Issue	Macroscopic	Micromachined	
Unwanted turbulent flow?	Y	N	
Very small dead volume?	varies	Y	
Problems purging bubbles?	N	Y	
Efficient liquid pumps available?	Y	not yet	
Efficient liquid valves available?	Y	not yet	
Efficient gas pumps available?	Y	N	
Efficient gas valves available?	Y	Y	
Simple interconnect scheme?	Y	N	
Chemical resistant materials available?	Y	varies	
Low power?.	N	varies	
Sub-cm ² volume?	N	Y	
High surface-area-to-volume ratio?	N	Y	
Batch fabricated?	N	Y (not packaging	

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WHAT IS A FLUID?

A **fluid** is a material (gas or liquid) that deforms continually under shear stress. This simply means that the material can flow and has no rigid three-dimensional structure. Under most circumstances (exceptions include extremes in ambient temperature and pressure), liquids and gases may be treated identically, with the exceptions that gases generally need complete containment and that gases are generally **compressible**, while liquids are generally **incompressible**.

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IDEAL GAS LAW

$\mathbf{PV} = \mathbf{nRT}$

- P = pressure, in Pa = N/m2
- V = volume, in m3
- N = number of moles (mol)
- R = gas constant, 8.3151 N m / mol K
- T = absolute temperature, in K

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BASIC FLUID PROPERTIES

Pascal's principle is a statement of the fundamental concept that pressure applied to an enclosed fluid is transmitted to every portion of the fluid (and hence the vessel it is in), and applies whether or not the fluid is incompressible.

Archimedes' principle states that the buoyant force acting on an immersed body is equal in magnitude (but acting in the opposite direction) to the force of gravity on the displaced fluid.

Viscosity, μ , is a measure of how resistant a fluid is to flow (e.g., honey is more viscous than water) and is analogous to friction between solid objects (conversion of mechanical energy into thermal energy). Viscosity can be found to be given in many differing units in the literature, but the most common is the poise (g/(s-cm)).

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VISCOSITY

Substance	Temperature (°C)	Viscosity (centipoise = 0.01 g/(s•cm)
Water	0	1.787
Water	20	1.002
Water	100	0.2818
Water Vapor	100	0.01255
Blood	37	4.5 to 5.5
Acetone	25	0.316
Ethanol	0	1.773
Ethanol	20	1.200
Isopropanol	15	2.86
Mercury	0	1.685
Mercury	20	1.554
Air	0	0.01708
Air	18	0.01827
Carbon Dioxide	0	0.01390
Carbon Dioxide	20	0.01480
Nitrogen	27.4	0.01781
Xenon	20	0.02260

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FORMULAS FOR HYDRAULIC DIAMETER

Cross Section	Formula	Variables	
Dircle $D_h = D$		D = diameter	
Annulus	$D_{h} = (D - d)$	d = inner diameter	
Rectangle	$D_{h} = \frac{2ab}{(a+b)}$	a, b = sides	
Triangle, equilateral	$D_{h} = \frac{\sqrt{3}}{3} a$	a = side	
Triangle, general	$D_{h} = \sqrt{\frac{16s(s-a)(s-b)(s-c)}{(a+b+c)}}$ where $s = \frac{1}{2}(a+b+c)$	a, b, c = sides	

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CAPILLARY FORCES

Assuming a round channel the capillary force is:

F1 = $2 \pi r \gamma \cos(\Theta)$ where Θ is the contact angle γ is the interfacial surface tension

Gravitational force in a vertical capillary:

$$\mathbf{Fg} = \rho \mathbf{g} \, \pi \, \mathbf{r}^2 \, \mathbf{h}$$

Contact	angle measurem	ient of a w	ater drop o	on a silicon	surface
RCA clean NH ₄ OH: H ₂ O ₂ : H ₂ H ₂ O: H ₂ O ₂ : N RCA clean and RCA clean and H ₂ SO ₄ : H ₂ O ₂ 30% H ₂ SO ₄ fo he end of the pr	$1:H_2O = 1:1:$ O = 1:1:6 for $H_4OH = 6:1:$ 65% HNO ₃ fo 2% HF for 10 m r 10 min retreatments the	6 for 10 r r 10 min a 4 for 10 r or 10 min) min tin e wafers v	nin at 75 it 75 °C, nin at 55 were alwa	°C, °C ·	in deionized w
pretreatment	direct after pretreatment	5 h	27 h	3 d	6 J
A	4.5°	5.5*	9°	16°	20°
в	5.5	4	5.5	7.5°	12*
D	675	619	4	12.5	10.5
E	34	01	03.3	74 7	1/
P	1 50	40	60	170	220

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Illustration of a process for forming buried, bulk-etched fluidic channels in a silicon substrate, and subsequently sealing them with a deposited thin-film layer. Adapted from Tjerkstra, et al. (1997).









FLOW CHANNELS

Photoresist, reflow, oxide, coating, Acetone removal







Packus of curvature: 52 pm



Reduce of ourseture: 15 price



Radius of curvature: 8 pm

Microscopic views of raised, hemispherical canals ranging from 8 to 100 µm in diameter.

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Chromatography

Glass gas chromatography chip for environmental testing

Posted In: R&D Daily | Analyzers | Gas Chromatography Systems | Glass | Lab Equipment

Tuesday, February 16, 2010



Dolomite, in collaboration with the UK's National Center for Atmospheric Science, has successfully tested the miniaturization of gas chromatography equipment for environmental testing. The glass Gas Chromatography Chip has a 300 µm thick layer and is fabricated with isotropic channels, which replace the capillary and spindle structure which is characteristic of standard GC columns. This microfluidic miniaturization enables the production of portable and low power GC systems suitable for environmental applications such as atmospheric monitoring.

The chip design includes an injection zone, which allows activated

carbon particles to be loaded and held, forming a sample absorption column. Closely packed within a 100 x 100 mm microfluidic chip, the 7.5 m and 1.4 m long channels have an internal diameter of 320 μm to ensure efficient heat transfer. With a circular cross section, a uniform coating can be evenly applied to the inside surface of the channel, effectively mimicking the stationary phase, to aid separation.



